The Analysis of WC surfaces and Diamond Thin Films by Laser-Acoustic Surface Waves





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Presentation Outline

Diamond Coating

- > Production flow
- Process and equipment
- Microstructure

Quality control by E-Modulus

- ➤ LAWave® equipment
- Measurement quantities

Results

- ➤ Overview LAWave® spectra
- Ground versus ground & etched
- Diamond coatings





Diamond Coating – Production Flow

QC **Coating Process** standard diamond smooth diamond QC **Pre-Treatment** etching additional treatment Incoming Material QC Co content Roughness standard or micro grain





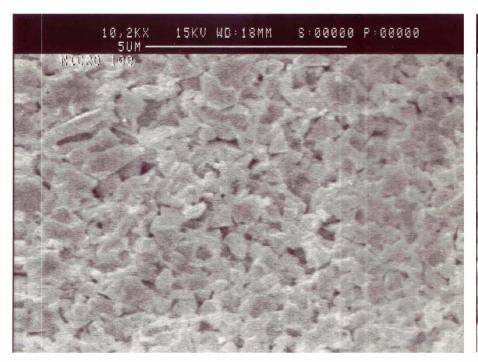
Diamond Coating – Equipment & Process

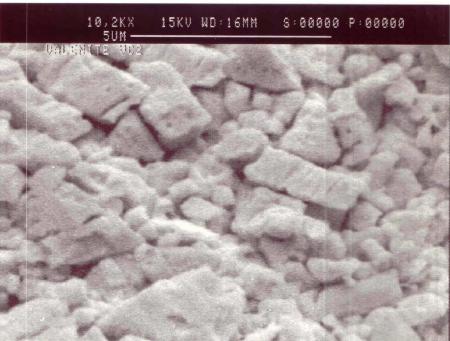






Diamond Coating - Micro vs. Standard Grain Substrate

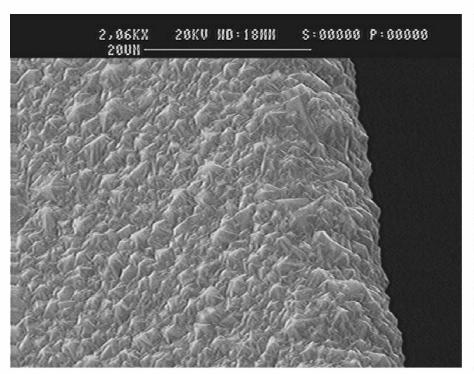


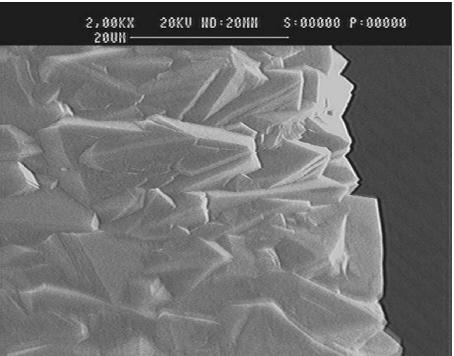






Diamond Coating - Smooth vs. Standard Grain Film









E-Modulus as Sensitive Quantity to Control Quality

E- modulus for some bulk and coating materials

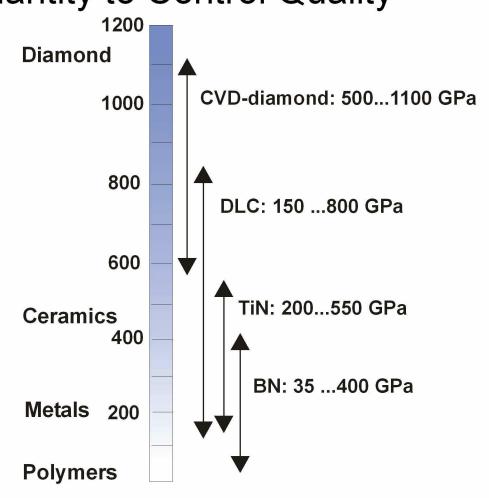
Highest modulus diamond (E = 1147 GPa)

Lowest modulus polymers

Coatings

Considerable variation depending on deposition parameters

→ Quality Control

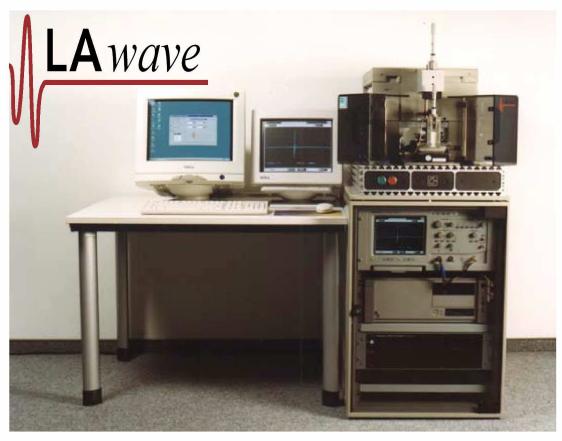






Laser-Acoustics LAWave – Equipment

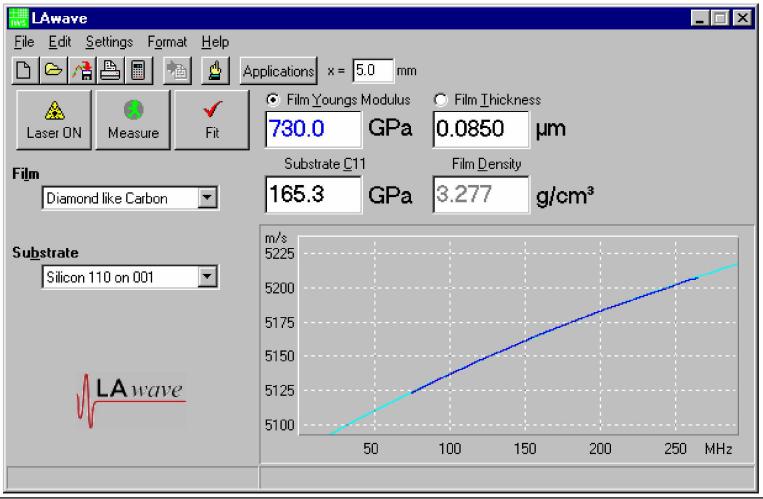








Laser-Acoustics LAWave® - Software Interface







Laser-Acoustics LAWave® – Characteristics

- Non-destructive measurement
- Fast measurement cycle→ < 2 min
- Accurate measurement cycle
 → ∆c/c = 2×10⁻⁴
- ➤ Easy-to-use equipment→ handling, software





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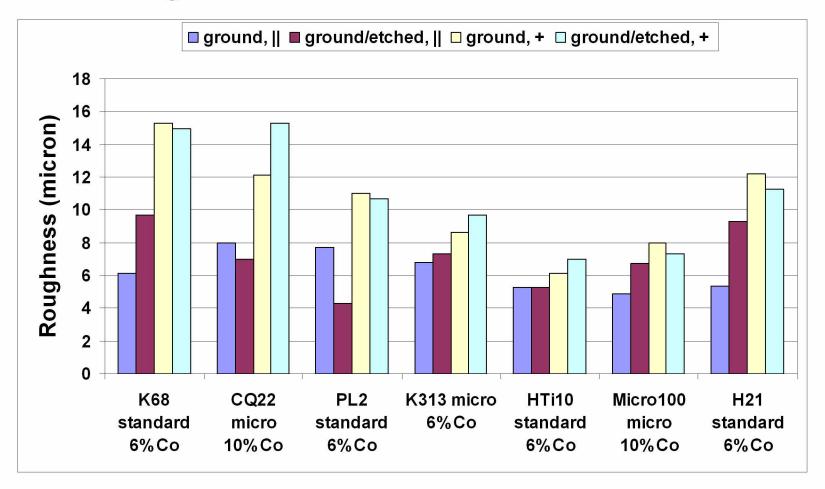
Results

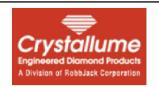
- ➤ Overview LAWave® spectra
- Ground versus ground & etched
- Diamond coatings





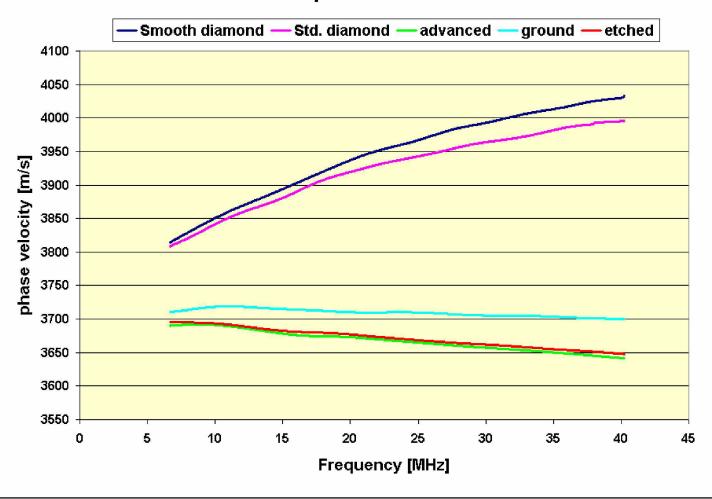
Results – Roughness of Ground and Etched Material







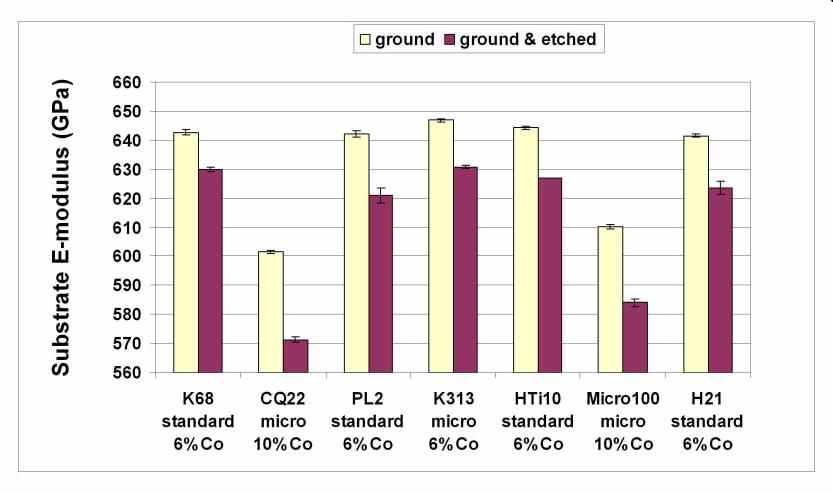
Results - Overview LAWave® Spectra

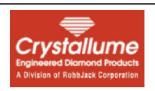






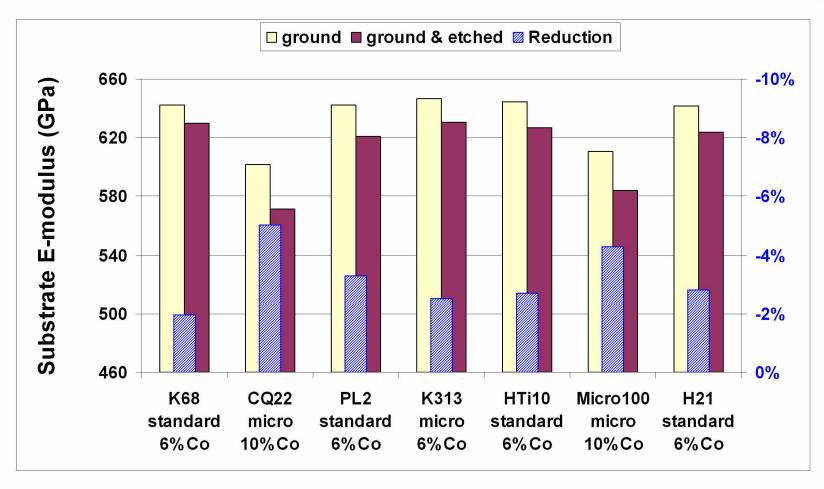
Results – Ground versus Ground & Etched Material (1)







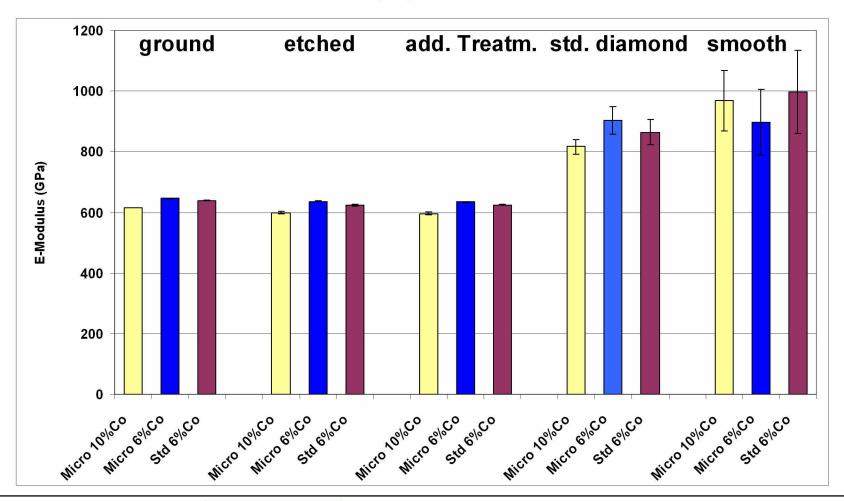
Results – Ground versus Ground & Etched Material (2)







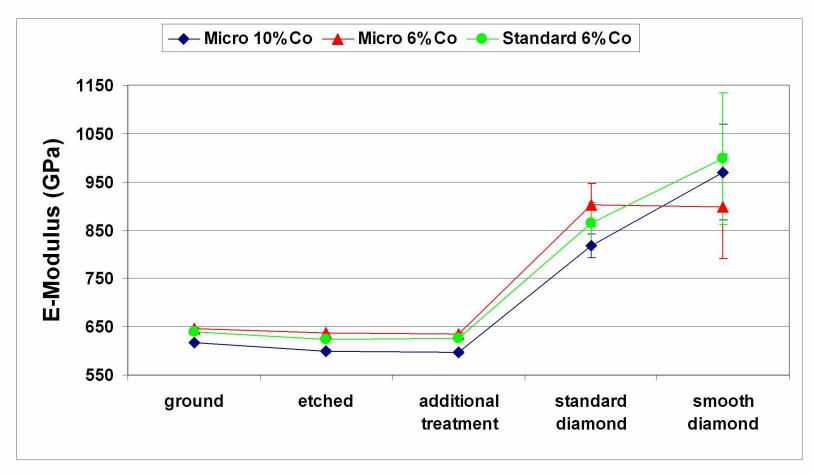
Results – Process Steps (1)







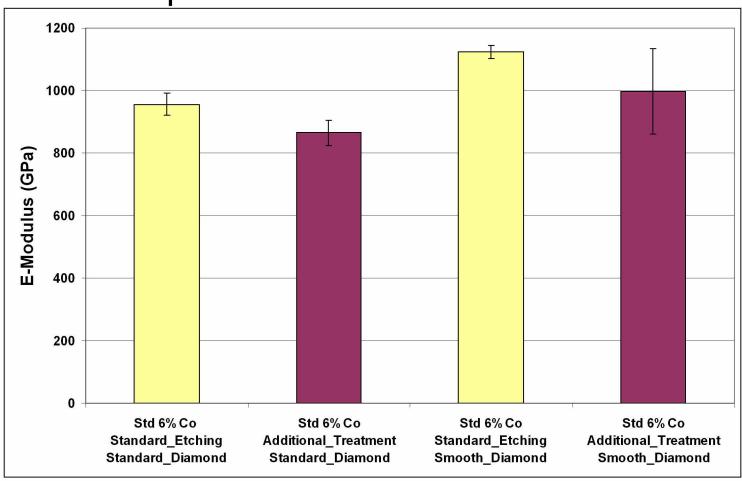
Results – Process Steps (2)







Results – Example Process Variations







Summary / Conclusions

- LAWave® as quality control and film development tool
 - ◆ Co% change from 5% ..10% very sensitively detected → can control incoming material
 - ◆ Effective E-modulus change due to etching (Co depletion) very sensitively detected → can control material prepared for coating
 - ◆ Effective E-modulus change due to different diamond coatings very sensitively detected → can control coating quality
 - Tool also proved successful to support film development
- Diamond coatings
 - Smooth diamond coating yields an effective E-modulus of (1123 ± 22) GPa





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